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Results of searching in PCT for: (PIEZOELECTRIC NEAR (LAYER* or laminat* or stack or plies)) and ((first or low* or high*) near "dielectric constant"): 0 records

[Search Summary]

Refine Search (PIEZOELECTRIC NEAR (LAYER* or laminat* or stack



No records matching your query found in PCT

Search Summary



PIEZOELECTRIC NEAR LAYER*: 746 occurrences in 375 records.

PIEZOELECTRIC NEAR laminat*: 77 occurrences in 39 records.

(PIEZOELECTRIC NEAR LAYER* OR PIEZOELECTRIC NEAR laminat*): 400 records.

PIEZOELECTRIC NEAR stack: 95 occurrences in 57 records.

((PIEZOELECTRIC NEAR LAYER* OR PIEZOELECTRIC NEAR laminat*) OR PIEZOELECTRIC NEAR stack): 442 records.

PIEZOELECTRIC NEAR plies: 1 occurrence in 1 record.

(((PIEZOELECTRIC NEAR LAYER* OR PIEZOELECTRIC NEAR laminat*) OR PIEZOELECTRIC NEAR stack) OR PIEZOELECTRIC NEAR plies): 443 records.

first NEAR "dielectric constant": 0 occurrences in 0 records.

low* NEAR "dielectric constant": 0 occurrences in 0 records.

(first NEAR "dielectric constant" OR low* NEAR "dielectric constant"); 0 records.

high* NEAR "dielectric constant": 0 occurrences in 0 records.

((first NEAR "dielectric constant" OR low* NEAR "dielectric constant") OR high* NEAR "dielectric constant"): 0

((((PIEZOELECTRIC NEAR LAYER* OR PIEZOELECTRIC NEAR laminat*) OR PIEZOELECTRIC NEAR stack) OR PIEZOELECTRIC NEAR plies) AND ((first NEAR "dielectric constant" OR low* NEAR "dielectric constant") OR high* NEAR "dielectric constant")): 0 records.

Search Time: 0.27 seconds.



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Search Results

10/10/2007 - 11:10:15

Search Query:

((piezoelectric)) <AND> (((stack or la

Query: ((piezoelectric)) <AND> (((stack or laminat* or layer* or multilayer*)) <in> abstract) <AND> ((("dielectric constant")) <in> claims)

9 documents out of 1926019 matched your query. Click on its number to view the details of the document.

Note: All document detail pages now appear on a new Browser Window.

1.	2561618	IMPROVED THICK FILM DIELECTRIC STRUCTURE FOR THICK DIELECTRIC ELECTROLUMINESCENT DISPLAYS	87%
2.	2271282	PROCESS FOR FABRICATING DEVICE COMPRISING LEAD ZIRCONATE TITANATE	82%
3.	2228741	ELECTRODING OF CERAMIC PIEZOELECTRIC TRANSDUCERS	82%
4.	2346059	INTEGRATED MULTILAYERED MICROFLUIDIC DEVICES AND METHODS FOR MAKING THE SAME	80%
5.	2106549	ULTRASONIC TRANSDUCERS	80%
6.	1154861	ULTRASONIC TRANSDUCER WITH A PIEZOELECTRIC PLASTIC RECEIVING LAYER	80%
7.	<u>2373613</u>	A MULTI-OUTPUT COMPOSITE PIEZOELECTRIC TRANSFORMER WITH EXPANSION VIBRATION MODE	77%
8.	2176347	ARRAY OF THIN FILM ACTUATED MIRRORS	77%

0 results found in the Worldwide database for: piezoelectric near laminat* in the title AND "dielectric constant" in the title or abstract (Results are sorted by date of upload in database)

Data supplied from the **esp@cenet** database - Worldwide

O results found in the Worldwide database for: piezoelectric near layer* in the title AND "dielectric constant" in the title or abstract (Results are sorted by date of upload in database)

Data supplied from the **esp@cenet** database - Worldwide

O results found in the Worldwide database for:
piezoelectric near stack in the title AND "dielectric constant" in the title or abstract (Results are sorted by date of upload in database)

Data supplied from the esp@cenet database - Worldwide

27 results found in the Worldwide database for:

"dielectric constant" and piezoelectric and first in the title or abstract

(Results are sorted by date of upload in database)

COMPLEX OXIDE FILM AND METHOD FOR PRODUCING SAME, DIELECTRIC MATERIAL INCLUDING COMPLEX OXIDE FILM. PIEZOELECTRIC MATERIAL, CAPACITOR, PIEZOELECTRIC ELEMENT AND ELECTRONIC DEVICE.

Inventor: SHIRAKAWA AKIHIKO (JP)

Applicant: SHOWA DENKO KK (JP); SHIRAKAWA

AKIHIKO (JP)

EC: C01G23/00; C01G23/00F4; (+6)

IPC: C01G23/00; C01B13/32; C25D11/18 (+13)

Publication info: WO2007013598 - 2007-02-01

Dielectric element, piezoelectric element, ink jet head and ink jet recording apparatus and manufacturing method of same

Inventor: MATSUDA TAKANORI (JP); IFUKU TOSHIHIRO Applicant: CANON KK (JP); WASA KIYOTAKA (JP)

EC: H01G4/12B2B; B41J2/14D2; (+8)

IPC: H01L41/09; B41J2/01; B41J2/045 (+8)

Publication info: TW255057B - 2006-05-11

LEAD-FREE PIEZOELECTRIC CERAMICS AND PREPARATION METHOD THEREOF

Inventor: CHO JEONG HO; KIM BYEONG IK; (+1)

Applicant: KOREA INST OF CERAMIC ENGINEER

IPC: CO4B35/46; CO4B35/46; (IPC1-7): CO4B35/46

Publication info: KR20040054965 - 2004-06-26

SURFACE ACOUSTIC WAVE ELEMENT AND COMMUNICATION **APPARATUS**

Inventor: YOKOTA HIROKO; YAMAGATA YOSHIFUMI;

Applicant: KYOCERA CORP

EC: H03H9/10S3; H03H9/02S4; (+2)

IPC: H03H9/25; H01L41/09; H01L41/18 (+4)

Publication info: JP2006042008 - 2006-02-09

Inkjet head unit

Inventor: SAKAIDA ATSUO (JP)

Applicant: BROTHER IND LTD (JP)

EC: B41J2/14D1 IPC: B41J2/045; B41J2/045

Publication info: US2006012649 - 2006-01-19

TEMPERATURE CALIBRATION OF PIEZOELECTRIC TRANSDUCERS

Inventor: ADORAM AVNER (IL); PESACH BENNY (IL) Applicant: GLUCON INC (US); ADORAM AVNER (IL);

(+1)

EC: H01L41/08; H01L41/113C IPC: H01L41/08; H01L41/113; H01L41/08 (+2)

Publication info: W003032409 - 2003-04-17

Ultrasound converter array comprises a number of elements consisting of piezoelectric ceramic layers and electrodes

Inventor: SMITH LOWELL SCOTT (US); WILDES

Applicant: GEN ELECTRIC (US)

DOUGLAS GLEN (US); (+1)

EC: B06B1/06C3E; H04R17/00

IPC: G01N29/24; A61B8/00; B06B1/06 (+15)

Publication info: **DE10155894** - 2002-09-12

Piezoelectric ceramic composition, and high power output transformer made of the same composition

Inventor: KIM JONG SUN (KR); YOO CHOONG SIK

Applicant: SAMSUNG ELECTRO MECH (US)

(KR); (+2)

EC: C04B35/493; H01L41/107; (+1)

IPC: CO4B35/49; CO4B35/493; H01L41/107 (+8)

Publication info: US2001054704 - 2001-12-27

PIEZOELECTRIC CERAMIC COMPOSITION, AND HIGH POWER

PIEZOELECTRIC TRANSFORMER

Inventor: KIN SHOSEN; RYU CHUSHOKU; (+2) Applicant: SAMSUNG ELECTRO MECH



Approximately 197 results found in the Worldwide database for: "dielectric constant" and piezoelectric and low* in the title or abstract (Results are sorted by date of upload in database)

PIEZOELECTRIC CERAMIC COMPOSITION AND PIEZOELECTRIC ACTUATOR

Inventor: YAMAMOTO A (JP); OGISO KOJI (JP); (+1)

Applicant: MURATA MANUFACTURING CO (JP)

EC: H01L41/187

IPC: CO4B35/493; CO4B35/49

Publication info: EP1840106 - 2007-10-03

2 Piezoelectric actuator

Inventor: WALTER GERHARD (DE); MANN ARMIN (DE) Applicant:

EC: H01L41/083; H01L41/053

IPC: H01L41/083; H01L41/053; H01L41/083 (+1)

Publication info: US2007152542 - 2007-07-05

COMPLEX OXIDE FILM AND METHOD FOR PRODUCING SAME. COMPOSITE BODY AND METHOD FOR PRODUCING SAME, DIELECTRIC MATERIAL, PIEZOELECTRIC MATERIAL, CAPACITOR AND ELECTRONIC DEVICE

Inventor: SHIRAKAWA AKIHIKO (JP)

Applicant: SHOWA DENKO KK (JP); SHIRAKAWA

AKIHIKO (JP)

IPC: C01G23/00; H01G4/12; H01G4/30 (+7)

Publication info: WO2007074875 - 2007-07-05

Dielectric element, piezoelectric element, ink jet head and ink jet recording apparatus and manufacturing method of same

Inventor: MATSUDA TAKANORI (JP); IFUKU TOSHIHIRO Applicant: CANON KK (JP); WASA KIYOTAKA (JP)

(JP); (+2)

EC: H01G4/12B2B; B41J2/14D2; (+8)

IPC: H01L41/09; B41J2/01; B41J2/045 (+8)

Publication info: TW255057B - 2006-05-11

PIEZOELECTRIC CERAMIC COMPOSITION AND PIEZOELECTRIC CERAMIC ELEMENT USING THE SAME

Inventor: SAKABE YUKIO; TAKEDA TOSHIKAZU

Applicant: MURATA MANUFACTURING CO

EC: C04B35/495

IPC: CO4B35/00; CO4B35/495; H01L41/09 (+8)

Publication info: KR20020018064 - 2002-03-07

PIEZOELECTRIC CERAMIC COMPOSITION

Inventor: CHO YEONG GUK; KIM WOL MYEONG

Applicant: LG INNOTEC CO LTD

EC:

IPC: CO4B35/497; CO4B35/495; (IPC1-7):

C04B35/497

Publication info: KR20040001719 - 2004-01-07

LOW TEMPERATURE SINTERING PIEZOELECTRIC CERAMIC **COMPOSITION FOR PARTS FEEDERS**

Inventor: CHO JEONG HO; CHOI BYUNG YUL; (+1)

Applicant: KOREA INST OF CERAMIC ENGINEER IPC: CO4B35/49; H01B3/12; H01G4/12 (+6)

Publication info: KR20050022105 - 2005-03-07

LOW TEMPERATURE SINTERED PSN-PZT-PNW COMPOSITION FOR PIEZOELECTRIC TRANSFORMERS AND PRODUCTION THEREOF

Inventor: WOO WON HEE; YOO JU HYUN

Applicant: YOO JU HYUN

IPC: C04B35/493; H01L41/187; C04B35/49 (+3)

Publication info: KR20050005686 - 2005-01-14

FLUID SENSOR BY USING SLIT ELASTIC WAVE

Inventor: CHEREDNICK VALENTIN (RU); CHOI YONG RIM (KR); (+1)

Applicant: LG INNOTEC CO LTD (KR)

EC:

IPC: GO1N11/00; GO1N11/00; (IPC1-7): GO1N11/00

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1	IS&R	L3		3648	(310/328,366).CCLS.	US- PGPUB ; USPAT ; USOCR ; FPRS; EPO; DERWE NT; IBM_T DB	2007/10/1 0 08:18	
2	BRS	$^{ m L4}$		2203	13 and (stack or plies or laminat\$4 or layer\$3)	1	2007/10/1 0 09:31	
(7)	BRS	L5		2220	l3 and (multilayer\$3 or stack or plies or laminat\$4 or layer\$3)		2007/10/1 0 09:32	·

	Туре	L	#	Hits	Search Text	DBs	Time Stamp	Comment
4	BRS	L6		147	15 and dielectric adj2 constant	1	2007/10/1 0 08:42	
5	BRS	L7		1	"20070069610"	į.	2007/10/1 0 08:25	
6	BRS	L8		1	17 and ("9" and dielectric adj2 constant)		2007/10/1 0 08:28	
7	BRS	L9		0	17 and ("Fig. 9" and dielectric adj2 constant)		2007/10/1 0 08:27	
8	BRS	L10)	1	17 and inactive		2007/10/1 0 08:28	
9	BRS	L11	-	1		1	2007/10/1 0 08:42	
10	BRS	L12		1	(10/00001).1111.	USPAT ; USOCR	2007/10/1 0 08:52	
11	BRS	L13	3	1	("2005/0046310").URPN.	$\Pi \cap C \cup \Delta \cap \Gamma$	2007/10/1 0 08:53	
12	BRS	L14			("5118982" "5861704" "6182340" "6215227" "6229247").PN.	;	2007/10/1 0 09:07	

	Туре	L #	Hits	Search Text	DBs	Time Stamp	Comment
13	BRS	L15	14114	stack or plies or laminat\$4 or layer\$3)		2007/10/1 0 09:33	
14	BRS	L16	14031	115 not 16	1	2007/10/1 0 09:33	
15	BRS	L17	17.72	l16 and "dielectric constant"	T	2007/10/1 0 09:34	